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	Class	Subclass
ISSUE CLASSIFICATION		

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E. SCANNED <u>AC2</u> Q.A. <u>WIT</u>	PATENT DATE
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APPLICATION NO. 09/851089	CONT/PRIOR: F	CLASS 015 134	SUBCLASS 77	ART UNIT 174A	EXAMINER CHIN COLE
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APPLICANTS

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00000000 Cleaning apparatus for semiconductor wafer

PTO-2040
12/89[illegible]

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